

Notice of References Cited	Application/Control No. 10/706,742		Applicant(s)/Patent Under Reexamination VAN RIETSCHOTE ET AL.	
	Examiner Hashem Farrokh		Art Unit 2187	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,754,781 B2	06-2004	Chauvel et al.	711/143
*	B	US-2003/0097422 A1	05-2003	Richards et al.	709/217
*	C	US-2004/0268340 A1	12-2004	Steeb et al.	717/174
*	D	US-2003/0126242 A1	07-2003	Chang, Albert H.	709/222
*	E	US-6,421,777 B1	07-2002	Pierre-Louis et al.	713/2
*	F	US-6,799,316 B1	09-2004	Aguilar et al.	718/1
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.